

OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

Application Data Sheet**Applicant Information**

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Izumi
Family Name::	FUSEGAWA
City of Residence::	Nishishirakawa-gun
Country of Residence::	Japan

Applicant Authority Type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Nobuaki
Family Name::	MITAMURA
City of Residence::	Nishishirakawa-gun
Country of Residence::	Japan

Applicant Authority Type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Takahiro
Family Name::	YANAGIMACHI
City of Residence::	Nishishirakawa-gun
Country of Residence::	Japan

Correspondence Information

Correspondence Customer Number::	25944
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Application Information

Application Type::	National Phase
Subject Matter::	Utility
CD-ROM or CD-R::	None

Title:: METHOD FOR PRODUCING A SINGLE
CRYSTAL AND SILICON SINGLE
CRYSTAL WAFER

Attorney Docket Number:: 126961

Suggested Drawing Figure:: 1

Total Drawing Sheets:: 5

Small Entity:: No

Representative Information

Attorneys associated with Customer No. 25944.

Domestic Priority Information			
Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	National Stage of	PCT/JP2004/011685	08/13/04
Foreign Priority Information			
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2003-296837	08/20/03	Yes
Assignee Information			
Assignee Name::		Shin-Etsu Handotai Co., Ltd.	
Street of mailing address::		4-2, Marunouchi 1-chome	
City of mailing address::		Chiyoda-ku	
State or Province of mailing address::		Tokyo	
Country of mailing address::		Japan	